

Docket No. 0163-0707-2X



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kenji MIWA, et al.

SERIAL NO: 09/158,099

GAU: 1725

RCE FILED: September 30, 2002

EXAMINER: LIN, K

FOR: METHOD OF REFINEMENT OF MICROSTRUCTURE OF METALLIC MATERIALS

RECEIVED
OCT 28 2003
TC 1700

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **three** month extension of time be granted to October 23, 2003 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated: